

Structure and Properties of Nano- and Microcomposite Coating Based on Ti–Si–N/WC–Co–Cr

A.D. POGREBNJAK^{a,b,c,*}, A.P. SHPAK^a, V.M. BERESNEV^d, M.V. IL'YASHENKO^b,
F.F. KOMAROV^e, A.P. SHYPYLENKO^{a,b}, M.V. KAVERIN^{a,b}, P.V. ZUKOVSKI^f,
Y.A. KUNITSKYI^a, D.A. KOLESNIKOV^g, O.V. KOLISNICHENKO^h AND N.A. MAKHMUDOVⁱ

^aG.V. Kurdyumov Institute for Metal Physics, NAS Ukraine, Kiev, Ukraine

^bSumy State University, Sumy Institute for Surface Modification, Sumy, Ukraine

^cSumy State University, 40007, Sumy, Ukraine

^dScience Center for Physics and Technology, Kharkov, Ukraine

^eBelarus State University, Minsk, Belarus

^fLublin Technical University, Lublin, Poland

^gBelgorod State University, Belgorod, Russia

^hO.E. Paton Welding Institute, NAS of Ukraine, Kiev, Ukraine

ⁱSamarkand State University, Samarkand, Uzbekistan

Using the two technologies: plasma-detonation and vacuum-arc deposition, we fabricated two types of coatings: Ti–Si–N/WC–Co–Cr/steel and Ti–Si–N/steel. We found that the top coating of Ti–Si–N nanostructured one with 12 to 15 nm grain sizes and $H = 40$ to 38 GPa hardness. A thick coating which was deposited using the pulsed plasma jet, demonstrated 11 to 15.3 GPa hardness, an elastic modulus (E) changing within 176 to 240 GPa, and tungsten carbide grain dimensions varying from 150 to 350 nm to several microns. An X-ray diffraction analysis shows that the coating has the following phase composition: TiN, (Ti,Si)N solid solution, WC, W₂C tungsten carbides. An element analysis was performed using energy dispersive spectroscopy (microanalysis) and scanning electron microscopy, as well as the Rutherford backscattering of ⁴He⁺ ion and the Auger electron spectroscopy. Surface morphology and structure were analyzed using scanning electron microscopy and scanning tunnel microscopy. Tests friction and resistance (cylinder-plane) demonstrated essential resistance to abrasive wear and corrosion in the solution. The decrease of grain dimensions ≤ 10 nm occurring in the top Ti–Si–N coating layer increased the sample hardness to 42 ± 2.7 GPa under Ti₇₂–Si₈–N₂₀ at.% concentration.

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1. Introduction

Nanocomposite materials as a class of nanomaterials are characterized by heterogeneous structure, which was formed by practically non-interacting phases with the grain dimensions 5 to 35 nm [1]. As a rule, the components of such structure are amorphous matrix and inclusions of nanocrystalline phases. These amorphous components agree in the best way with the nanocrystalline surfaces providing good adhesion and essentially increasing hardness. Small grain dimensions of the second phase in combination with good strength of intergrain boundaries provide high mechanical properties of such composition materials.

Today nanomaterials are divided into three classes according to their hardness values: hard nanocomposites of $H \geq 20$ to 40 GPa hardness, superhard of 40 to 80 GPa,

and ultrahard of ≥ 80 GPa [2]. In addition to the protecting functions, chemical and machine building industries need restoration of initial tool dimensions for the tools, which already function in industry. For these purposes, tools covered with thick coatings, the physical and mechanical properties of which are higher than those of basic material. Usually, the alloys (powders) Ni–Cr–Mo, the hard alloys WC–Co–Cr and Cr₃C₂–Ni, and oxide ceramics Al₂O₃, Al₂O₃–Cr₂O₃ are used for such coatings [3].

In such way, combination of two layers, for example a thick layer of WC–Co–Cr hard alloy of 100 μ m, which was formed using cumulative or detonation deposition, and Ti–Si–N thin upper layer (units of a micron) with enhanced physical-mechanical characteristics, which was formed by subsequent condensation, was able to provide higher protecting functions and restore worn surface regions.

The aim of this work is manufacturing of Ti–Si–N-, Ti–Si–N/WC–Co–Cr-based coatings and investigation of their physical and mechanical properties.

* corresponding author; e-mail: alexp@i.ua

2. Experimental details

The polished samples of Steel 45 (0.45% C, Fe the rest) of 4 mm and 20 mm diameters were coated using a vacuum-arc source with high-frequency discharge. The Ti alloyed sintered cathode containing 5 to 10 wt% of Si was deposited using the Bulat 3 T-device functioning under 5×10^{-5} Pa vacuum and 100 A cathode current. The sputtering was carried out using two regimes: the standard vacuum-arc method, and high-frequency (HF)-regime. A bias potential was applied to the substrate from the HF generator, which produced impulses of convergent oscillations with ≤ 1 MHz frequency, the duration of impulse was 60 μ s, their repetition frequency — about 10 kHz. Due to HF diode effect the value of negative auto bias potential occurring in the substrate amounted to 2 to 3 kV at the beginning of impulse (after start of discharger operation). The coatings of 2 to 3.5 μ m thickness were deposited on the steel substrates of 20 and 30 mm diameters, and 3 to 5 mm thickness without additional substrate heating. Molecular nitrogen was employed as a reactive gas. The first series of rounded steel 3 (0.3 wt% C) samples of 20 mm diameter and 4 to 5 mm thickness were deposited using the cumulative-detonation device CDS-1 of the following parameters: 65 mm distance to a nozzle cut, 14 mm/s displacement velocity, 5 runs, 12 Hz pulse repetition frequency (for WC-Co-Cr). After the deposition, the 160 to 320 μ m thick coating was melted by plasma jet (without powder) using eroding W electrode. A melted layer thickness was 45 to 60 μ m. Then, the Ti-Si-N thin coating of about 3 μ m was deposited over the thick one using the same device Bulat 3 T (the method was described above).

For element analysis, we applied the following methods: Rutherford backscattering of $^4\text{He}^+$ of 1.76 MeV energy (RBS), scanning electron microscopy (SEM) with energy dispersive spectroscopy (EDS) (REMMA-103M, Selmi, Ukraine), X-ray diffraction (DRON-3 and Advantage 8, USA).

Hardness and elastic modulus were measured using the nanoindentation device — Nanoindenter II, MTS System Corporation, Oak Ridge TN (USA) with the Berkovich pyramid. Elastic modulus was determined using the “load-unload” curves, according to the Oliver-Pharr method [1, 3]. Scanning tunneling microscope (STM) of 1 nm resolution was used to study the thin layer surface morphology.

3. Results and discussion

The cumulative-detonation device functioned under the conditions of detonation burning combustion gaseous mixtures. The cumulative-detonation device functioned under conditions of detonation burning of combustion gaseous mixtures. The device (Fig. 1) was constructed of the following parts. The detonation chamber (1) serves to burn gaseous combustion mixtures. Cumulative detonation chamber (2) works at any concentrations of combus-

tion mixtures and allows formation of high-velocity gas jet with excess nitrogen or carbon. The cylindrical nozzle (3) serves for heating and acceleration of powders. It was manufactured of copper tubes and could be adopted to any cross-section configuration. Its output diameter was 10 to 30 mm. The component (4) feeds and stops gaseous mixtures. To initiate detonation, we applied a sparking plug (5). A device has input for a mixture of gaseous components (6).

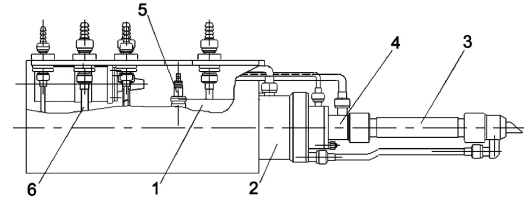


Fig. 1. The cumulative-detonation device. 1 — detonation chamber, 2 — cumulative detonation chamber, 3 — cylindrical nozzle, 4 — gas feeding component, 5 — sparking plug, 6 — device input.

Basic difference between the cumulative-detonation and detonation devices is that the former utilized combined energies of detonation combustion products from several specially designed chambers. Cumulative energy allows high-velocity gas to flow with several shock waves providing efficient interactions with powder material. In this way, energy of combustion mixtures is rationally used. The rate and temperature of combustion products depend only on combustion conditions in every chamber. Nozzles function not less than 1000 h. High burning frequency of 15 to 30 Hz is able to provide quasi-continuous coating deposition.

To increase the potential of technological system, the generator, which allows reaching up to 100 kW impulse of HF discharge, was constructed on the basis of pulsed generator with impact contouring.

An advantage of such generators is that their operation weakly depended on changes of loading impedance, which was principally important for functioning under pulsed mode and under pulsed loading.

Discharge starts at aluminum coils, then it displaces to copper electrodes with good heat conductivity. The discharge unit has special holes for air cooling of plates. Application of such construction provides high voltages and generator operation stability.

Spark resistance of discharge units was calculated using the perfect Tampller formula [4]:

$$R = 2.5 \times 10^{-8} f/c, \quad (1)$$

where c is the capacity value, which was discharged with f operating frequency.

Operating parameters for the tested generator with $f_0 = 1$ MHz, $\rho = -10 \Omega$, $C = T_{pf}$, $L = 5 \mu\text{G}$, $U_0 = 10$ kV, $t_{ipl} = 30 \mu\text{s}$, stored capacitor energy was $E_0 = 2.5$ J, pulsed power $P_{\text{pulse}} = 8.3$ kW. The calculation demonstrated that under periodical discharge

$t_{\text{pulse}} = 1.5 \mu\text{s}$, $P_{\text{pulse}} = 1.6 \text{ MW}$, repetition frequency $f = 3.0 \text{ kHz}$, $t_{\text{rep}} = 330 \mu\text{s}$, an average power $P = 7.5 \text{ kW}$, discharge current $I = 10^3 \text{ A}$.

HF generator, which switches plasma-producing antennae, operates in two modes: (1) with open input (ohmic circuit—zero distance between the antenna and ground) and (2) with closed input — the antenna is separated from the ground by capacity.

Charged plasma particles in the electric HF field of the antenna E reached the following velocity:

$$V = \frac{eE}{mw}, \quad (2)$$

where e is the particle charge, m is the particle mass, w is the cyclic generator frequency.

Then, the particle range in the field E and under w frequency will be

$$Z_{\text{max}} = \frac{eE}{mw^2}. \quad (3)$$

Selecting E and f such that an electron range was several centimeters (cm), ion remaining practically non-mobile, and the antenna HF voltage started to be detected by plasma.

Under the closed input mode, the antenna was negatively charged, and under the open input mode, electrons left the zone of antenna.

Without the external magnetic field this zone is

$$\delta \approx \frac{c}{2\pi \times 10^4 \sqrt{n_e}}, \quad (4)$$

where c is the light velocity [m/s], n_e is the plasma density [cm^{-3}].

In such way, working with the decreasing voltage (Fig. 2) during every impulse, one can join two main technological operations of coating deposition (clearing and deposition), which earlier were performed separately using the devices for vacuum-arc deposition.

It allows to choose better conditions for coating deposition and to save time. Depositing Al_2O_3 and TiN coatings, it was demonstrated that changing HF voltage potential applied to the substrate, one could affect coating phase composition [1–4].

Figure 3 represents the image of nano-microcomposite surface for the combined Ti-Si-N/WC-Co-Cr coating.

A thin coating is formed using the vacuum-arc source and follows the coating surface relief formed by plasma-detonation. Its average roughness varies from 14 to 22 μm (after melting and coating deposition using the vacuum-arc source). An image of X-ray energy dispersion spectrum is presented below. It indicates the following element concentrations in the thin coating: $N \approx 7.0$ to 7.52 vol.%; $Si \approx 0.7$ vol.%; $Ti \approx 76.70$ to 81 vol.%. For the thick coating we found $Fe \approx 0.7$ vol.%, and traces of Ni and Cr.

Figure 4 presents the RBS data for the thick WC-Co-Cr coating without Ti-Si-N thin one, and the results for the combined coating are presented below.

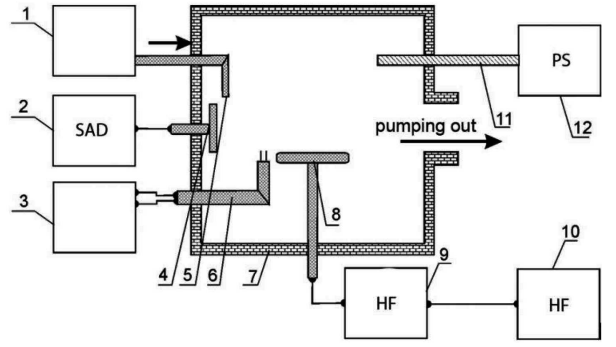


Fig. 2. A scheme of the technological system for coating synthesis operating on the basis of vacuum-arc discharge: 1 — the gas-feeding device, 2 — the sources for arc-discharge feeding, 3 — the measuring probe, 4 — the cathode, 5 — the gas line for gas-feeding, 6 — the double movable probe, 7 — the vacuum chamber, 8 — the substrate, 9 — the device to match the HF-generator, 10 — the HF-generator, 11 — the quartz tube for dissociation of working gas molecules, 12 — the power source.

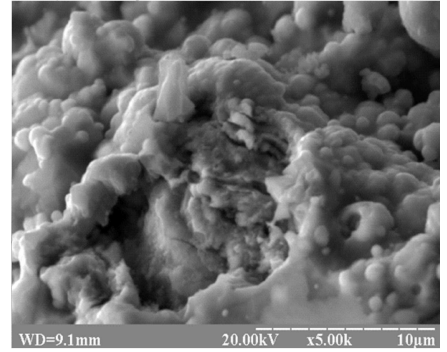


Fig. 3. Images of surface regions for the nano-microcomposite combined coating Ti-Si-N/WC-Co-Cr.

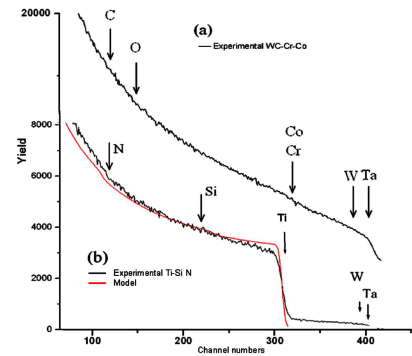


Fig. 4. (a) Energy spectra of the RBS for the thick coating WC-Co-Cr. (b) Energy spectra of the RBS for the top thin coating Ti-Si-N/WC-Co-Cr.

The element distribution, which was calculated according to standard program [5], indicated N = 30 at.%; Si \approx 5 to 6 at.%; Ti \approx 63 to 64 at.%. The spectrum of thick coating did not allow us to evaluate the element concentration due to high surface roughness of the coating formed by the plasma-detonation method.

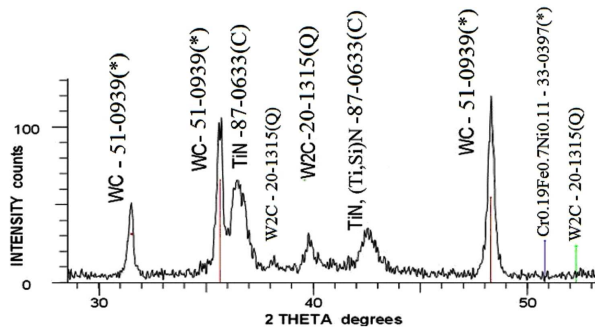


Fig. 5. Diffraction patterns fragments obtained for the surface region of the nano-microcomposite combined coating Ti-Si-N/WC-Co-Cr/steel substrate.

The X-ray analysis of the combined nanocomposite coating is shown in Fig. 5. It indicates the following phases: (Ti,Si)N; TiN — for the thin coating, and WC; W_2C — for the thick one.

Special samples were prepared for hardness measurements. Their surfaces were grinded and then polished. After grinding, thickness of WC-Co-Cr thick coating decreased to 80–90 μm . A thin Ti-Si-N film of about 3 μm was deposited on the grinded surface. As a result, we found that the hardness of different regions essentially varied within 30 ± 4 GPa to 38 ± 6 GPa. Probably, it is related to non-uniformity of plasma-detonation coating surface, whose hardness varied up from 11.5 to 15.3 GPa. These hardness values remained after deposition of the Ti-Si-N thin coating. Elastic modulus also features non-ordinary behavior.

Hardness of the thin coating, which was deposited to a polished steel Steel45(0.45%C) surface had the maximum value of 45 GPa, and its average value H_{av} was 45 GPa. Variation of hardness values was lower than that found in a combined coating.

Figure 6 shows the dependences of loading-unloading for various indentation depths.

The dependences and calculations, which were performed according to the Oliver-Pharr technique [1, 4], show that the hardness of Ti-Si-N coatings deposited on thick WC-Co-Cr was 37.0 ± 4.0 GPa under $E = 483$ GPa.

In the coating, basic phases are Cr_3Ni_2 for the bottom thick coating and (Ti,Si)N and TiN for the thin top coating. Diffraction patterns were taken under cobalt emission. Additionally, we found phases of pure Cr and low concentration of titanium oxide (Ti_9O_{17}) at interface boundary between the thin-thick coatings. The peaks of Ti-Si-N and TiN coincided because of low Si content. (Ti,Si)N is a solid solution based on TiN (Si penetra-

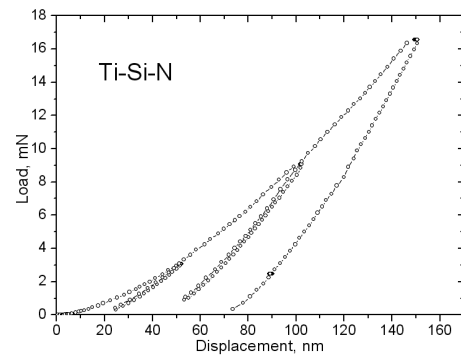


Fig. 6. Loading-unloading curves for the Ti-Si-N/WC-Co-Cr coating under various Berkovich indentation depths.

tion). The phases are well distinguished at 72 to 73° angles [6–8].

The results of wear resistance tests, which were performed according to the scheme “cylinder-plane”, demonstrated the lowest friction wear for the Ti-Si-N/WC-Co-Cr system and the highest friction wear for the substrate [9–11].

Adhesion between the thin Ti-Si-N coating and the thick WC-Co-Cr one was 1.75 times larger than that between Ti-Si-N and WC-Co-Cr. In addition, the adhesion between the thick WC-Co-Cr coating and steel (substrate) was 7.2 times larger and more than 12.5 times larger than between the thick WC-Co-Cr coating and steel (substrate) respectively. The maximum adhesion value of about 2920 N/m^2 was found in the case of Ti-Si-N \rightarrow WC-Co-Cr [12].

4. Conclusion

The thick (> 100 μm) nanocomposite coatings of Ti-Si-N/WC-Co compositions were formed and investigated.

In the first series of samples, thin coatings contained (Ti,Si)N and TiN phases. Grain sizes were about 25 nm. Hardness was about 30–38 GPa.

In the second series of samples, in thin coating the grain dimensions were smaller — about 15 nm. The hardness reached 42 to 45 GPa. The phase composition was the same — (Ti,Si)N and TiN. Si and N concentrations changed from 10 at.% to 5 at.% for Si and from 30 at.% to 20 at.% for N.

Wear resistance increased essentially, which was demonstrated by cylinder-to-sample surface friction. Corrosion resistance and other mechanical characteristics also increased.

Acknowledgments

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